Application No. 10/586,593 Paper Dated April 2, 2008 Attorney Docket No. 4605-062147

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.

10/586,593

Confirmation No. 1650

**Applicants** 

MASATAKA NAKAHARA

Filed

July 19, 2006

Title

POLISHING METHOD AND POLISHING FILM FOR USE

IN THE POLISHING METHOD

Group Art Unit

2874

Examiner

Not Yet Assigned

Customer No.

28289

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

## INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to the requirements of 37 C.F.R. §§ 1.56, 1.97, and 1.98, Applicant hereby submits this Information Disclosure Statement, which includes a completed Form PTO/SB/08a and one copy of each non-U.S. reference listed thereon.

The above-referenced application is the United States national phase of PCT Application No. PCT/JP2004/018387. A copy of the PCT International Search Report (ISR) was filed with the U.S. Patent & Trademark Office on July 19, 2006 as part of the national stage entry. A copy of an English-language translation of the International Preliminary Report on Patentability (IPRP) is attached for the Examiner's convenience.

> I hereby certify that this correspondence is being electronically submitted to the United States Patent and Trademark Office on April 2,

2008.

04/02/2008

Date

Kay E. Yetter

Typed Name of Person Signing Certificate

The ISR cites U.S. Patent Application Publication No. 2003/0029095, Japanese Patent Application Publication Nos. JP 2003-211351, JP 2003-510446, JP 2000-263449, JP 2001-240849, JP 2004-268152 and JP 2004-055732 and PCT Application Publication No. WO 01/23485, listed on Form PTO/SB/08a. The attached copies of JP 2003-211351, JP 2000-263449, JP 2001-240849, JP 2004-268152 and JP 2004-055732 are accompanied by partial English-language translations. JP 2003-510466 corresponds to WO 01/23485 and US 2003/0029095.

Japanese Patent Application Publication No. 9-248771, listed on Form PTO/SB/08a, is cited in the specification at page 1, lines 12-13. The attached copy of this reference is accompanied by a partial English-language translation.

Attached is a Notification for Reasons for Refusal for counterpart Japanese Application No. 2004-015237, which cites Japanese Patent Application Publication Nos. JP 2001-240849, JP 2000-326211, JP 2004-022804, JP 2003-211351 and JP 10-273648, listed on Form PTO/SB/08a. The attached copies of JP 2000-326211, JP 2004-022804 and JP 10-273648 are accompanied by English-language abstracts.

Pursuant to 37 C.F.R. § 1.97(b)(3), no fee is due for the submission of this Information Disclosure Statement, which is being filed before the mailing of a first Office Action on the merits. However, the Commissioner for Patents is hereby authorized to charge any additional fees which may be required to Deposit Account No. 23-0650. Please refund any overpayment to Deposit Account No. 23-0650.

By

Respectfully submitted,

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